Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE: NEW ASSIGNMENT

NATURE OF CONVEYANCE: ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Yukiko Arizono	12/09/2009
Kazuyuki Ishibashi	12/09/2009
Yoshikatsu Fujii	12/09/2009

RECEIVING PARTY DATA

Name:	Hitachi Global Storage Technologies Netherlands B.V.	
Street Address:	Locatellikade 1, Parnassustoren	
City:	Amsterdam	
State/Country:	NETHERLANDS	
Postal Code:	1076 AZ	

PROPERTY NUMBERS Total: 1

Property Type	Number	
Application Number:	12642734	

CORRESPONDENCE DATA

Fax Number: (831)722-2350

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

Phone: 408-377-0500

Email: bdinapoli@wagnerblecher.com

Correspondent Name: HITACHI C/O WAGNER BLECHER LLP

Address Line 1: 123 WESTRIDGE DRIVE

Address Line 4: WATSONVILLE, CALIFORNIA 95076

ATTORNEY DOCKET NUMBER: HJP920080089US1

NAME OF SUBMITTER: Desiree Chavez

Total Attachments: 1

source=HJP920080089US1_ASSG#page1.tif

126427

CH \$40,00

PATENT REEL: 023680 FRAME: 0041

ASSIGNMENT FOR PATENT APPLICATION

Whereas, I/we the undersigned inventor(s) have invented certain improvements as set forth in the patent application entitled:

DISK DRIVE SPIN CONTROL

Whereas, Hitachi Global Storage Technologies Netherlands B.V., having a place of business at Locatellikade 1, Parnassustoren, 1076 AZ Amsterdam, The Netherlands (hereinafter referred to as "HITACHI"), desires to acquire the entire right, title and interest in the said application and invention, and to any United States and foreign patents to be obtained therefore;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, I/we, the above named, hereby sell, assign, and transfer to HITACHI, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and we request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to HITACHI, its successors and assigns; and we hereby agree that HITACHI may apply for foreign Letters Patent on said invention and we will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by HITACHI.

Signed on the date(s) indicated beside my (our) signature(s).

古国的202

1)	Signature: / / / / / / / / / /	Date:	09 / DEC/ 2004
2)	Signature: 石模 和美 Typed Name: Kazuyuki ISHIBASHI	Date:	09/DEC/2009

Signature: 藤井 表勝 Typed Name: Yoshikatsu FUJII Date: 09/DEC/2009 3)

Docket No.: HJP920080089US1

RECORDED: 12/18/2009

Page 1 of 1

PATENT REEL: 023680 FRAME: 0042